

PATENT ASSIGNMENT

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CONVEYING PARTY DATA	
Name	Execution Date
Harvard University	03/09/2009
RECEIVING PARTY DATA	
Name:	National Science Foundation
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PROPERTY NUMBERS Total: 1	
Property Type	Number
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Invention Title: Fabrication of Thin, Metallic Films along the Sidewalls of a Topographically Patterned Stamp and Their

Application in Charge Printing

Inventor(s): Xu, Qiaobing; Winkleman, Adam; Whitesides, George M.; Cao, Tingbing

U.S. Filing/Issue Date: Application Serial No./Patent No.: 1/24/2008 11/989,345

Grant/Contract Number(s): DMR-0213805; PHY-0117795; W911NF-04-1-0170

Foreign Applications filed/intended in (countries): _____

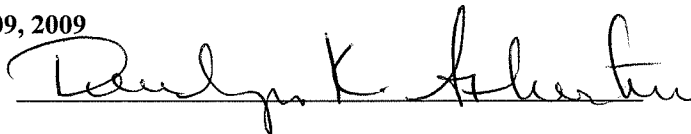
The invention identified above is a Subject Invention under **35 U.S.C. 200, et seq.**, and the Standard Patent Rights clause at **37 CFR 401.14, FAR 52.227-11** or **FAR 52.227-12** (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:

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Signed this **Monday, March 09, 2009**

By Denlyn K. Atherton



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